

**Search Notes**

Application/Control No.

10/661,736

Examiner

Richard H. Kim

Applicant(s)/Patent under  
Reexamination

LAI, CHUAN DE

Art Unit

2871

**SEARCHED**

| Class | Subclass              | Date      | Examiner |
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| 362   | 27,31,559,<br>560,561 | 5/23/2005 | RHK      |
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**INTERFERENCE SEARCHED**

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**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

|             | DATE      | EXMR |
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